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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of Gerald T. Mearini, James A. Dayton, Jr.

Serial No.: 10/772,444

Art Unit: 1722

Filed: February 6, 2004

Examiner: Felisa C. Hiteshew

Title: FREE-STANDING DIAMOND STRUCTURES AND METHODS

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

This Information Disclosure Statement is submitted pursuant to 37 C.F.R.

19.7(c)(2). Accordingly, a check in the amount of \$180.00 is submitted herewith.

The documents below are listed for your consideration in the examination of the subject application.

US PATENTS AND PUBLISHED APPLICATIONS:

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A copy of the below listed documents are enclosed for consideration in the

examination of the subject application.

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